EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S439	187284	((optical or laser or information) near5 (disc or disk or media or medium)).ti.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 15:29
S440	16779	S439 and ((dielectric or protective) near3 (film or layer))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 15:30
S441	14451	((heat or thermal or protect$4) near4 (film or layer)) same (ALN or "AL-N" or SiC or "SI-C" or (silicon adj carbide) or (aluminum adj nitride))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 15:32
S442	8195	((heat or thermal or protect$4) near4 (film or layer)) with (ALN or "AL-N" or SiC or "SI-C" or (silicon adj carbide) or (aluminum adj nitride))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 15:32
S443	678	S440 and S442	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 15:32
S444	426	S443 and @ad<"20020422"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 15:33
S445	49499	(dual or plural or plurality or multi or multiple or two or several or many or "2") near3 ((record$4 or reproduc$4 or data or information) near3 (film or layer))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 15:44

S446	260	S444 and S445	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 15:47
S447	30	"6096399"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 15:55
S448	2	"6096399".pn.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 15:55
S449	1	WO-03074282-$.did.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 17:34
S450	9	("heat radiation layers").ti.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 17:36
S451	1	("thermal radiation layers").ti.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 17:38
S452	715	((Ag or silver or metal or metallic or reflection or reflective) near2 (film or layer)) adj3 (ALN or "Al-N" or (aluminum adj nitride) or SIC or "Si-C" or (silicon adj carbide))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 17:39
S453	19	S452 and ((optical or laser or information) near5 (disc or disk or media or medium)).ti.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 17:40

S454	1487	((Ag or silver or metal or metallic or reflection or reflective) near2 (film or layer)) adj3 (ALN or "Al-N" or (aluminum adj nitride) or SIC or "Si-C" or (silicon adj carbide) or (heat near2 (diffus$4 or dispers$4 or transfer$4)) or (thermal near2 (diffus$4 or disper $4 or transfer$4)))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 17:44
S455	150	S454 and ((optical or laser or information) near5 (disc or disk or media or medium)).ti.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 17:45
S456	62	S455 and @ad<"20020422"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 17:46
S457	67	(thermodiffusion or thermaldiffusion) near2 (film or layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 18:02
S458	40	S457 and @ad<"20020422"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 18:02
S459	2	JP-2002288881-$.did.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 18:05
S460	2	"20020054983"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 18:08
S461	1	"20020054983" and ("21")	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 18:08

S462	187284	((optical or laser or information) near5 (disc or disk or media or medium)).ti.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/06/05 18:12
S463	49499	(dual or plural or plurality or multi or multiple or two or several or many or "2") near3 ((record$4 or reproduc$4 or data or information) near3 (film or layer))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 18:20
S464	12543	S462 and S463	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 18:33
S465	227	((heat or thermal) near2 (film or layer)) adj4 ((first or "1st") near2 ((protective or dielectric) adj2 (film or layer)))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 18:34
S466	75	S463 and S465	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 18:35
S467	21	S466 and @ad<"20020422"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 18:35
S468	267134	(ALN or "AL-N" or (aluminum adj2 nitride) or SIC or "si-C" or (silicon adj2 carbide))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 18:36
S469	9	S467 and S468	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 18:36

S470	4	"6149999"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 18:43
S471	205	(ALN or "AL-N" or (aluminum adj2 nitride) or SIC or "si-C" or (silicon adj2 carbide)) adj4 ((first or "1st") near2 ((protective or dielectric) adj2 (film or layer)))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 18:50
S472	90	S471 and @ad<"20020422"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 18:51
S473	76720	(deformation or deformed or deform) with (substrate or base)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 19:21
S474	811443	(ALN or "AL-N" or (aluminum adj2 nitride) or SIC or "si-C" or (silicon adj2 carbide) or thermal or heat or protect$4) near3 (film or layer)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 19:21
S475	3139	S473 same S474	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/05 19:22

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